

Qualify

Microencapsulation Electrostatic Processing System (MEPS) Data Description 121f02 Sensor 250.0 sa/sec (100.00 Hz) Hanning, k = 3448

LAB1O2, ER1, Drawer 1 Location Inc/Flight Increment: 5, Flight: UF2 Plot Type spectrogram

Notes:

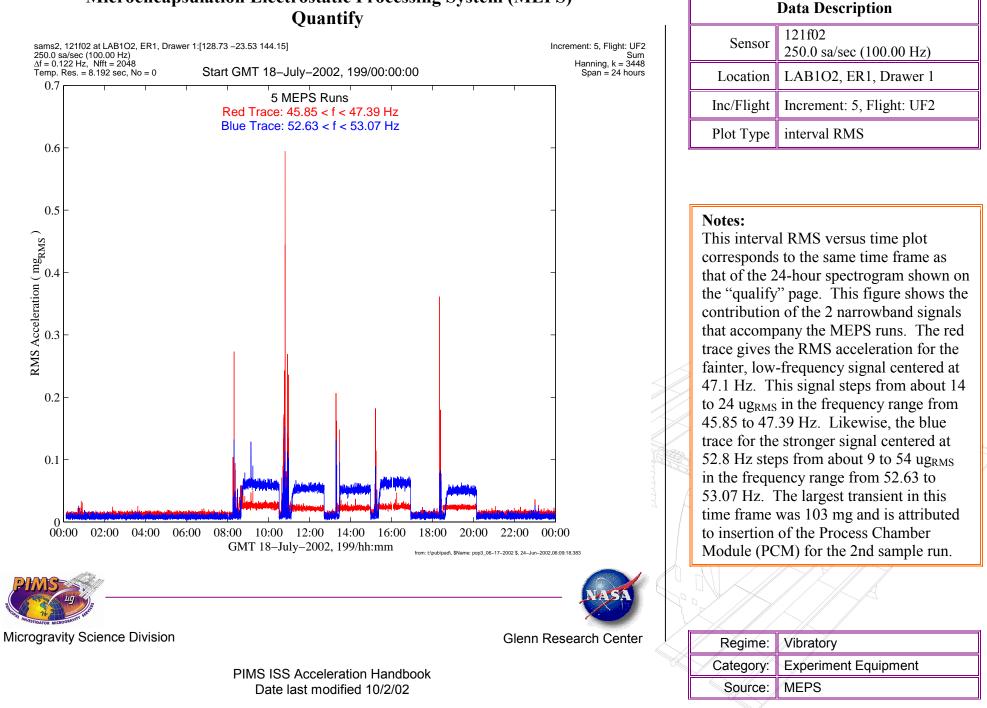
The MEPS is located in locker #8 of ER1 (LAB1O2) near the 121f02 sensor in RTS drawer 1. This 24-hour spectrogram readily shows 5 MEPS sample runs with the start/stop delimited by 2 narrowband signals. The weaker of these was centered at 47.1 Hz and the stronger at 52.8 Hz. Note that each of the 5 runs is preceded by the impulsive events of Process Chamber Module (PCM) insertion.

Microgravity Science Division

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Glenn Research Center

Regime: Vibratory Experiment Equipment Category: Source: MEPS



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